



## SMALL PITCH, HIGH RESOLUTION – SCALING OF OLED DISPLAYS

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# DISPLAY TRENDS

# LARGE-AREA DISPLAYS



# CURVED DISPLAYS



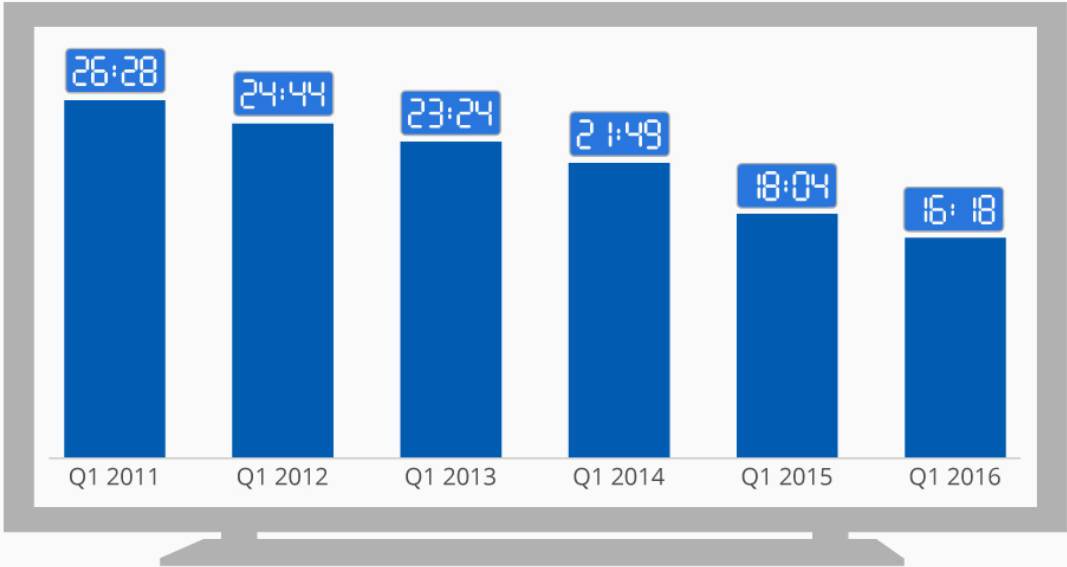
# FLEXIBLE DISPLAYS



# CONTENT MOVES TO MOBILE

## Young Americans Turn Their Backs on Traditional TV

Weekly time Americans aged 18-24 spend watching traditional TV (hh:mm)\*



CC BY ND  
@StatistaCharts

\* traditional TV includes all live and DVR/time-shifted TV viewing  
Source: Nielsen

statista

# MOBILE IS THE NEW INFORMATION PLATFORM



# AUGMENTED REALITY





# AUGMENTED REALITY



# AUGMENTED REALITY



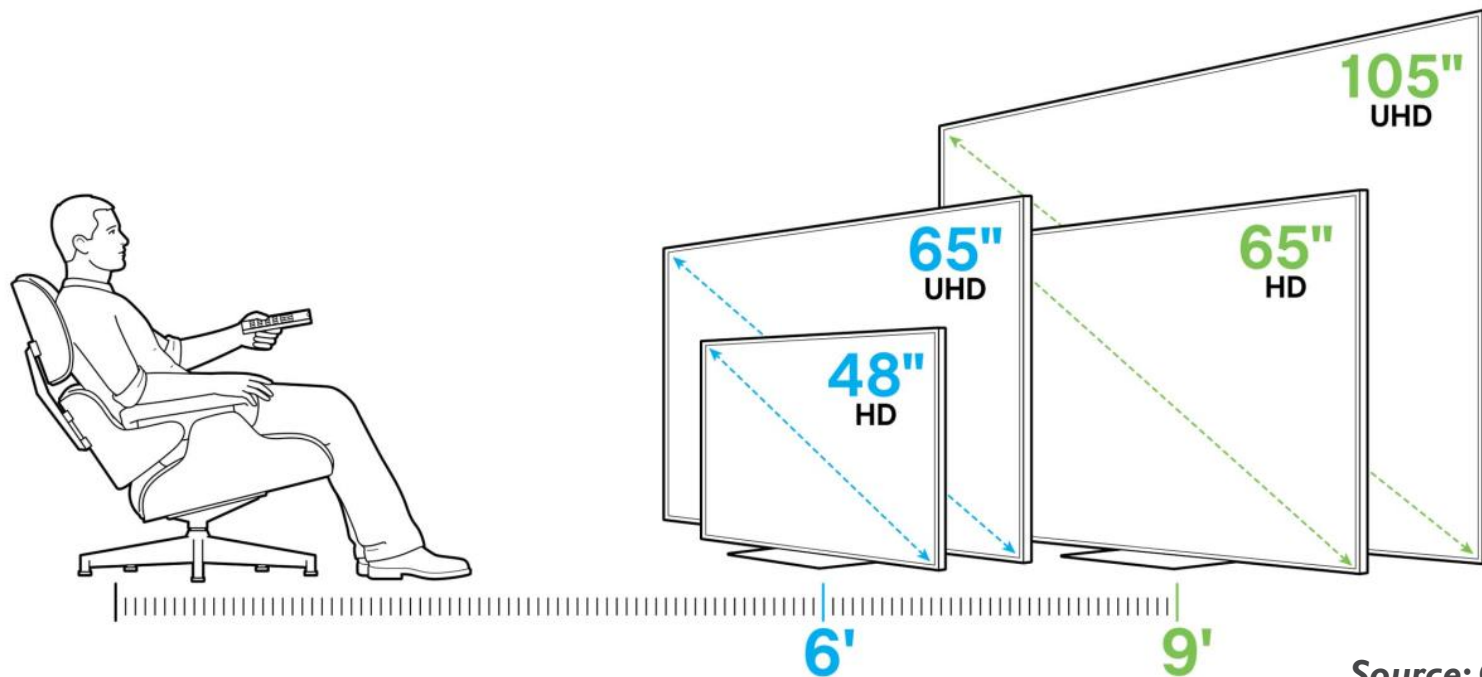
# VIRTUAL REALITY



COMMON REQUIREMENT:  
SMALL PITCH, HIGH RESOLUTION

# HIGH RESOLUTION BENEFITS

## SHORTER VIEWING DISTANCE WITH UHD



Source: Consumer Reports

# HIGH RESOLUTION BENEFITS

## “NATURAL 3D” FEELING

- sufficiently high resolution (8K) results in stronger depth sensation  
*ref: Tsushima et al., IDW'14 (VHF6-4L)*
- enabler for glass-free 3D



# HOW SMALL ARE PIXELS IN 8K DISPLAYS?

## PIXELS GETTING SMALLER

- 245  $\mu\text{m}$  pitch for 85 inch TV
- 16  $\mu\text{m}$  pitch for 5.5 inch smartphone
- 2  $\mu\text{m}$  pitch for microdisplay

# 8K



85"  
104 ppi  
245  $\mu\text{m}$



13"  
680 ppi  
38  $\mu\text{m}$



5.5"  
1600 ppi  
16  $\mu\text{m}$



0.5"  
>15 Kppi  
2  $\mu\text{m}$

display size  
resolution  
pixel pitch

# SMARTPHONE DISPLAY EVOLUTION

## RESOLUTION INCREASING ABOVE 800 PPI

- important for smartphone VR goggles
- 800 ppi desired for CJK characters
- difficult to go over 1000 ppi



**Apple**  
iPhone 7 Plus  
LCD  
5.5 inch  
401 ppi



**Huawei**  
P9  
LCD  
5.2 inch  
423 ppi



**Google**  
Pixel XL  
AMOLED  
5.5 inch  
534 ppi



**HTC**  
One M9+  
LCD  
5.2 inch  
565 ppi



**Samsung**  
Galaxy S7  
AMOLED  
5.1 inch  
577 ppi



**Sony**  
Xperia Z5 Premium  
LCD  
5.5 inch  
806 ppi



**Sharp**  
prototype  
panel  
1008 ppi



**PPI**



# HEAD-MOUNT DISPLAY EVOLUTION

## SMARTPHONE VS. MICRODISPLAY GOGGLES

- high aperture ratio (no “screen-door effect”)
- > 1000 ppi resolution
- gap between panels and microdisplays



**Sony**  
PS VR  
OLED  
386 ppi



**Oculus**  
Rift CV1  
OLED panels  
455 ppi / eye



**HTC**  
Vive  
OLED panels  
455 ppi / eye



**Samsung**  
Gear VR + GS7  
μdisplay  
577 ppi



**Sharp**  
prototype  
panel  
1008 ppi



**eMagin**  
WUXGA Color XL  
μdisplay  
2630 ppi



**MicroOLED**  
SXGA RGBW  
μdisplay  
2687 ppi

**PPI**

**FPD PANEL**

**MICRODISPLAY**

# AUGMENTED REALITY EVOLUTION

## IMAGE ON TOP OF WORLD VIEW

- high brightness ( $\gg 1000$  nit)
- maximum transparency
- lower field-of-view needed than in VR



**Fraunhofer**  
prototype  
 $\mu$ display  
320x240 px



**Google**  
Glass  
 $\mu$ display  
640x360 px



**Vuzix**  
M300  
 $\mu$ display  
640x360 px



**Solos**  
Vista  
 $\mu$ display  
640x360 px



**Microsoft**  
HoloLens  
'light engine'  
1268x720 px / eye



**Epson**  
Moverio BT-300  
 $\mu$ display  
1280x720 px

## AR DEVICES RESOLUTION

# COMPONENTS FOR NEXT-GEN DISPLAYS

- **8K resolution** → natural 3D; large viewing angle
- **high aperture ratio** → no “screen-door effect”
- **transparency** → augmented reality
- **high brightness** → outdoor viewing
- **low power** → wearable electronics
- **flexible substrates** → portability; light weight

- **AMOLED**

# AMOLED DISPLAYS AT IMEC / HOLST

ENGLAND

# IMEC (LEUVEN, BE) / HOLST CENTRE (EINDHOVEN, NL)

Amsterdam

The Hague

Netherlands

Rotterdam

Oxford

London

Antwerp

Ghent

Brussels

Belgium

imec



3500 people

Holst Centre

Open Innovation by imec and TNO



200 people

Frankfurt

Luxembourg

Mannheim

Karlsruhe

Stuttgart

Strasbourg

Paris

English Channel

ersey

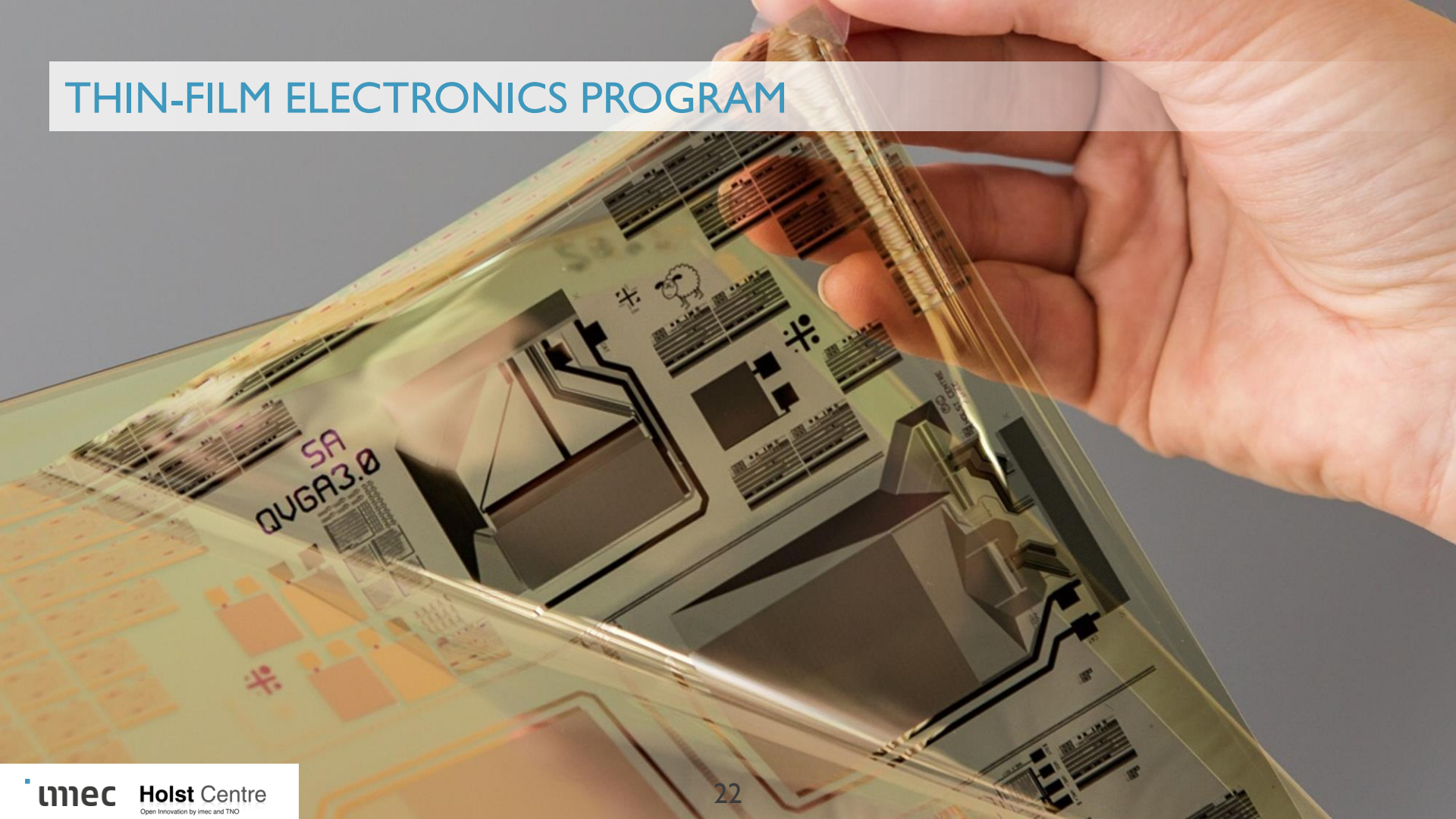
Jersey

imec

Holst Centre

Open Innovation by imec and TNO

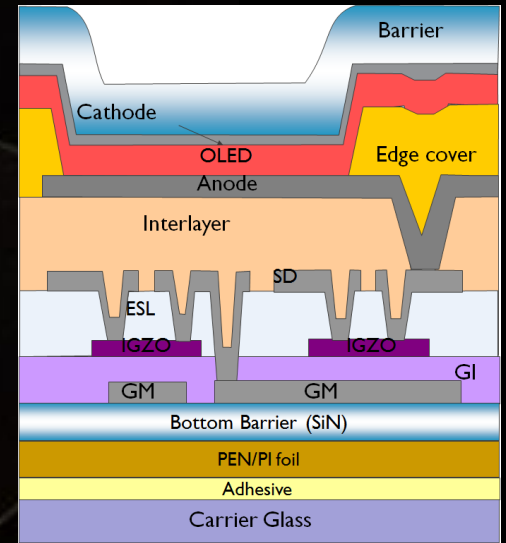
# THIN-FILM ELECTRONICS PROGRAM



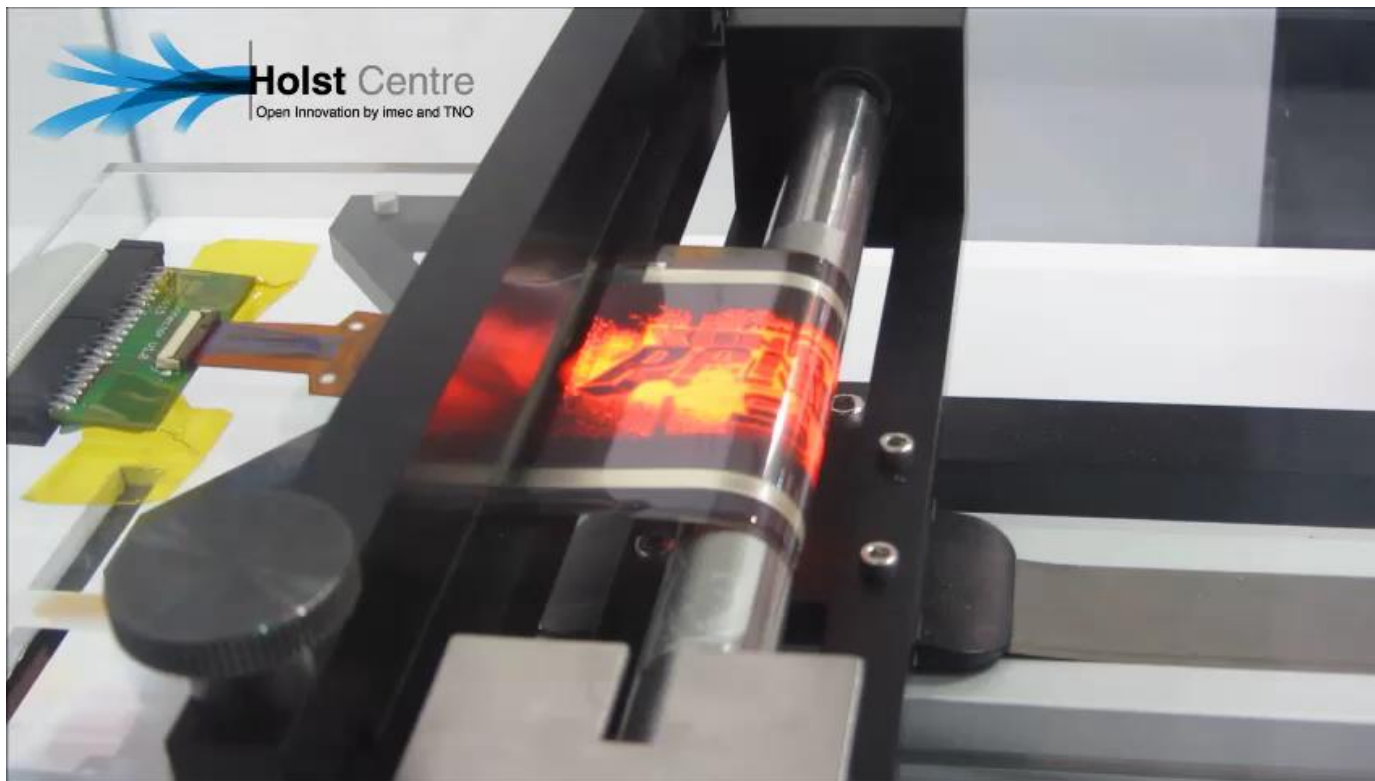
# IMEC/HOLST AMOLED DISPLAYS

**IGZO backplane**  
**OLED frontplane**  
**GENI substrate**  
**165 process steps**

Diagonal	4.0 inch
Resolution	QVGA, 320 ppi
Pixel Circuit	2T1C
OLED Type	Top-Emission
Display Driving	IC / in-panel
Substrate	PEN or PI

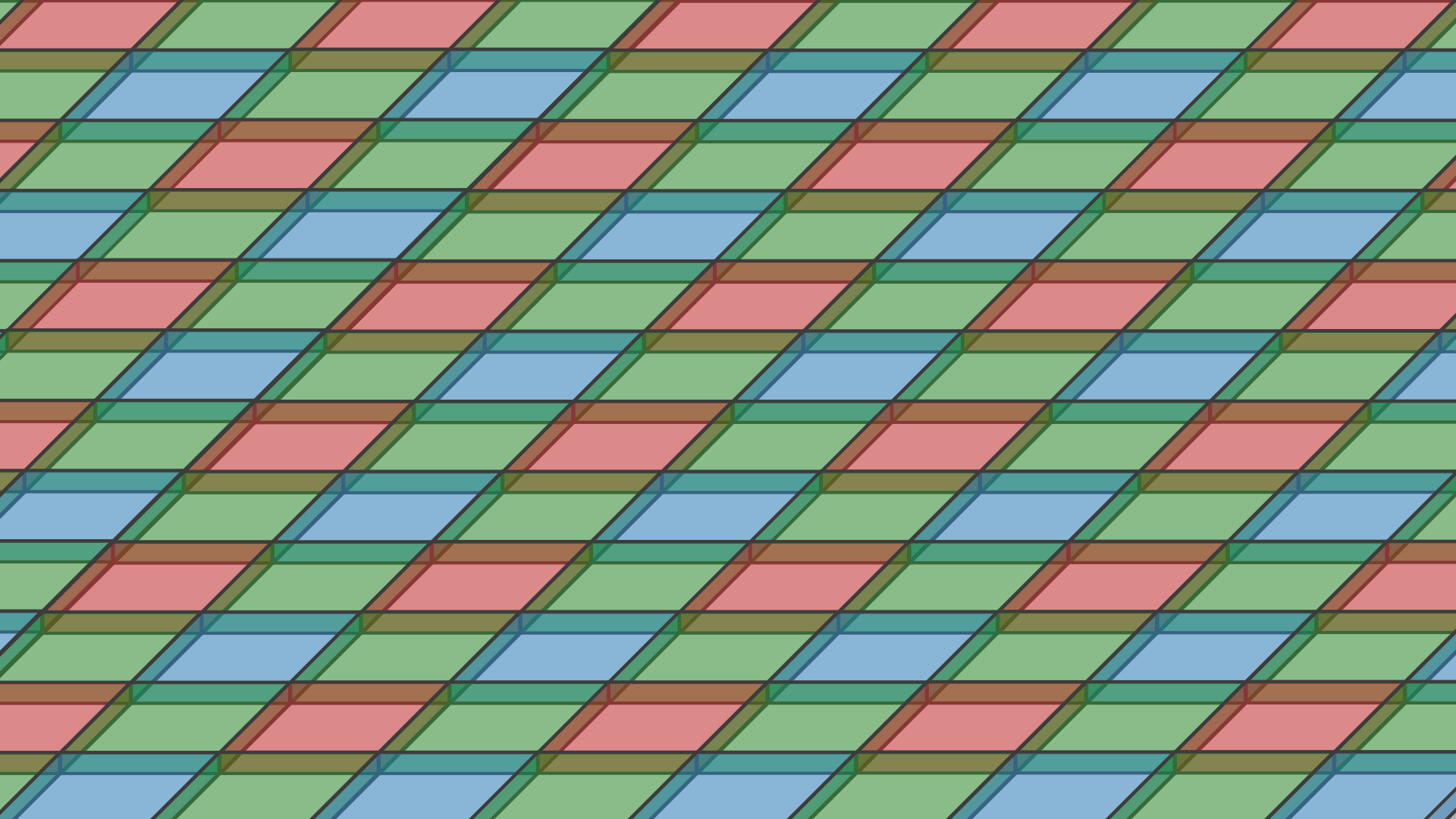


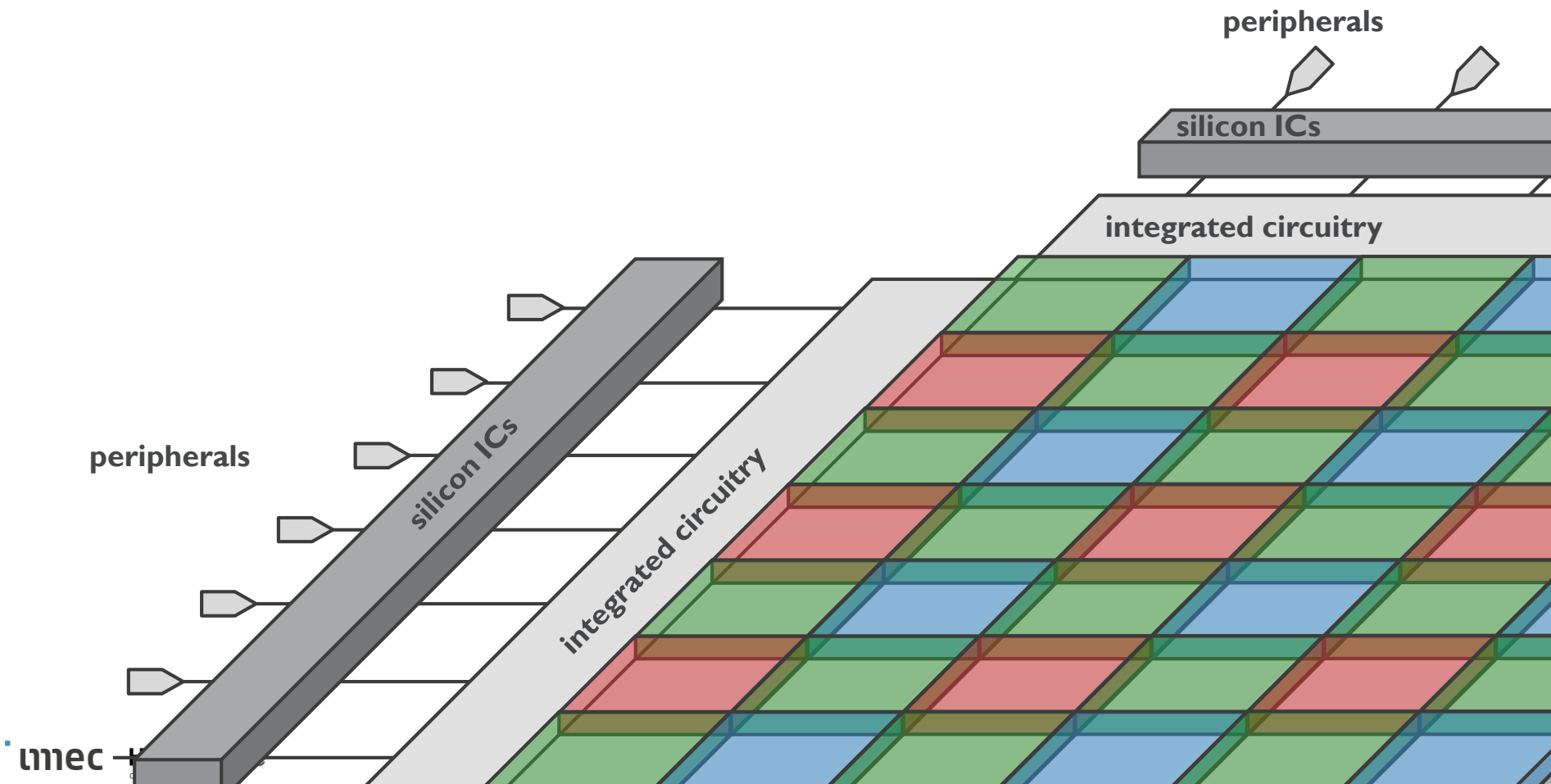
# IMEC/HOLST DEMO AT TOUCH TAIWAN 2015





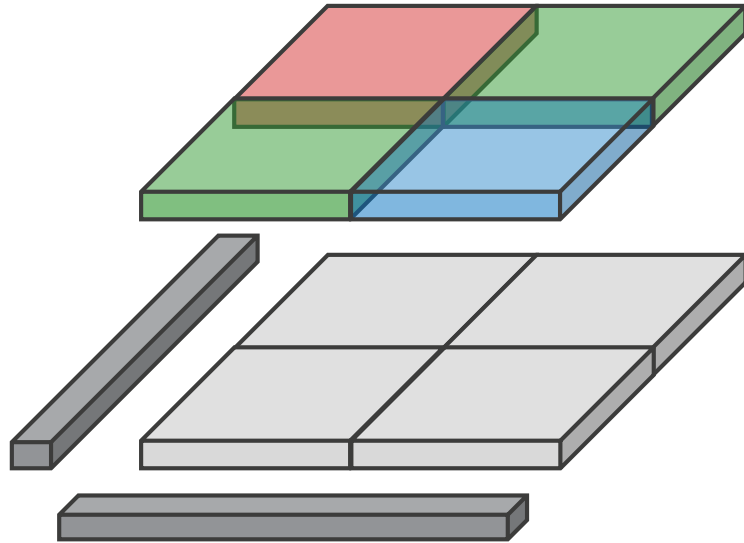
# SCALING AMOLED DISPLAYS





# TOWARDS HIGHER PIXEL DENSITY

IMPROVEMENTS IN 3 AREAS:



**FRONTPLANE**

**RGB resolution**  
**higher aperture ratio**

**BACKPLANE**

**better semiconductors**  
**compact architectures**  
**process resolution**

**DRIVING**

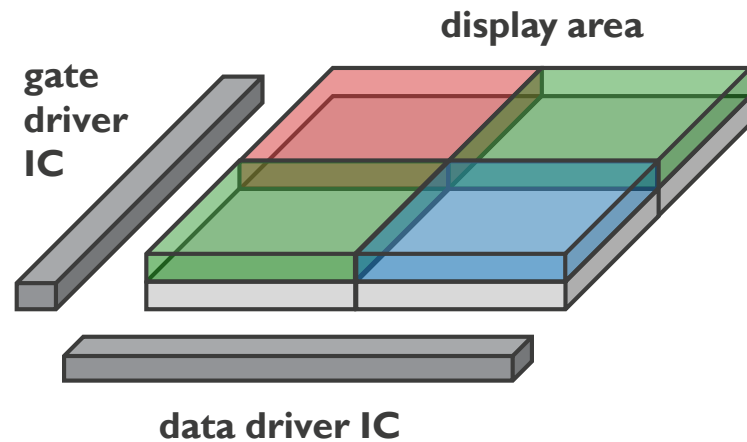
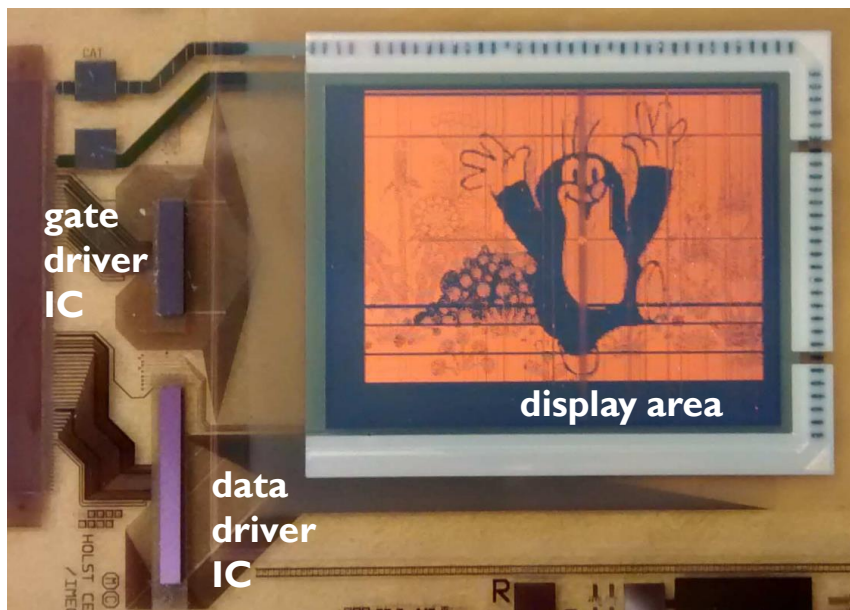
**integrated drivers**  
**PWM scheme**



# DRIVING SCHEMES

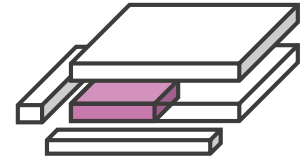
# DRIVING AMOLED DISPLAYS

## DISPLAY + EXTERNAL DRIVER CHIPS

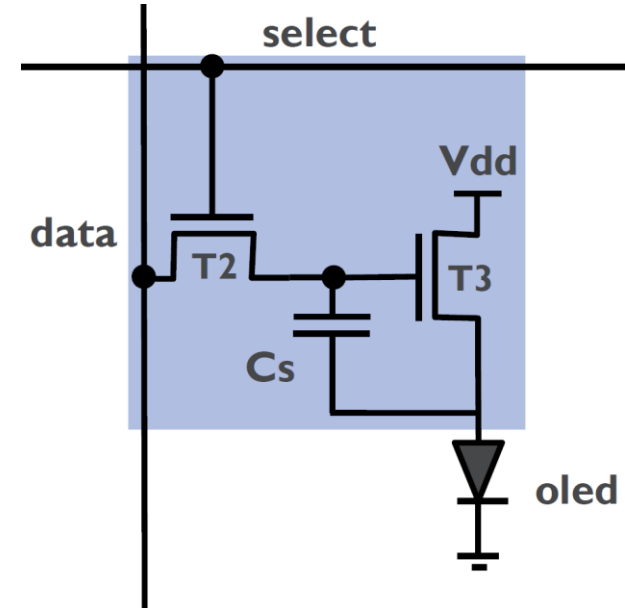


# DRIVING SCHEMES

## NEW PIXEL ENGINES

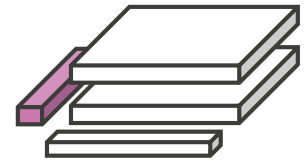


- current driving needed for OLEDs
  - compensation necessary
  - current pixel design:  $> 4T$
  - difficult to squeeze in 1000 ppi backplanes
- simpler pixels needed
  - scalable 2T1C or 3T2C
  - compensation moves off-backplane

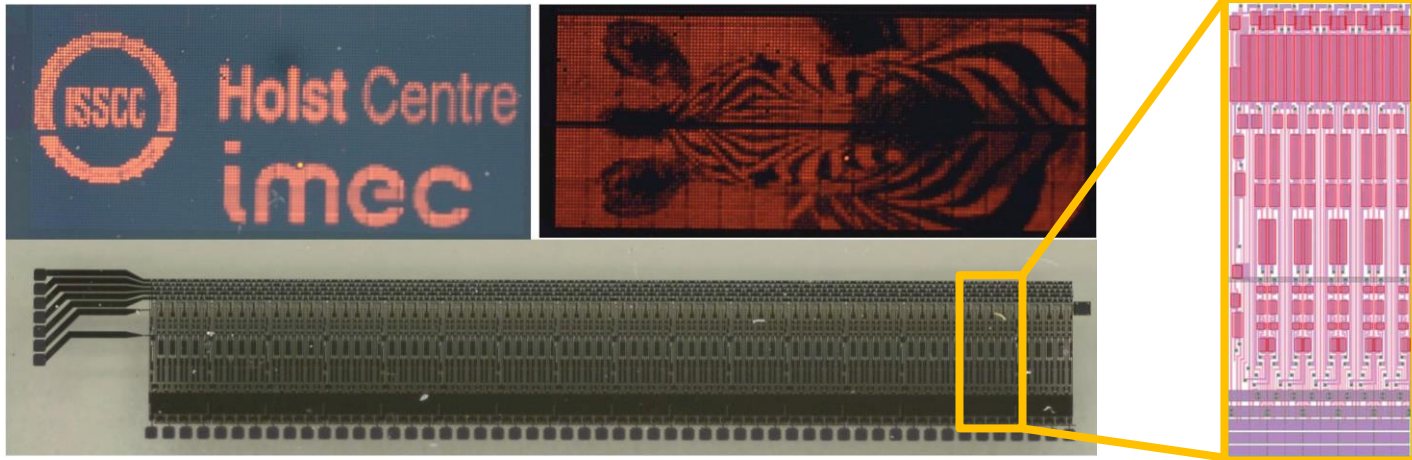


# DRIVER INTEGRATION

## IN-PANEL GATE DRIVER



- New gate drivers:
  - preferably integrated 'in panel'
  - adapted to new driving schemes

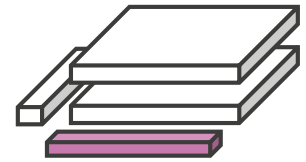


Jan Genoe et al., ISSCC 2014

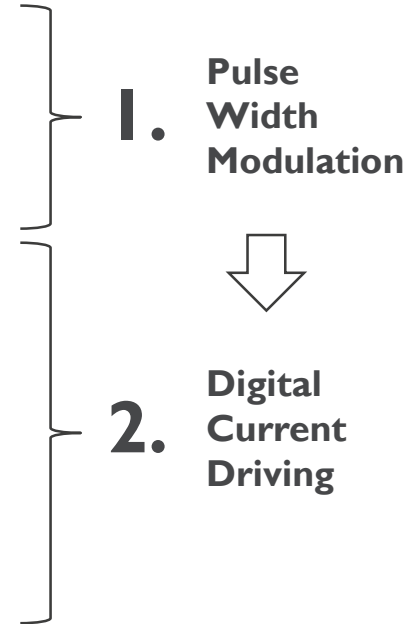


# NEW OLED DISPLAY DRIVING SCHEMES

## COMBINING HIGH RESOLUTION WITH COMPENSATIONS



- PWM: radically different way to feed the data
  - OLED has 100% duty cycle, no OLED overdrive for full brightness
- Split the most significant bits over multiple subframes
  - No motion artifacts
- Current comes from silicon ICs
  - Accurate light output, allowing 16 bit grey levels
- Compensation for TFT/OLED non-uniformity and degradation possible
  - Using sporadic calibration scans
  - Corrections happen in the driver  $\Rightarrow$  simple pixels
- Transistor used as a switch in the linear region
  - Lowers power consumption (power loss in TFT can be minimized)



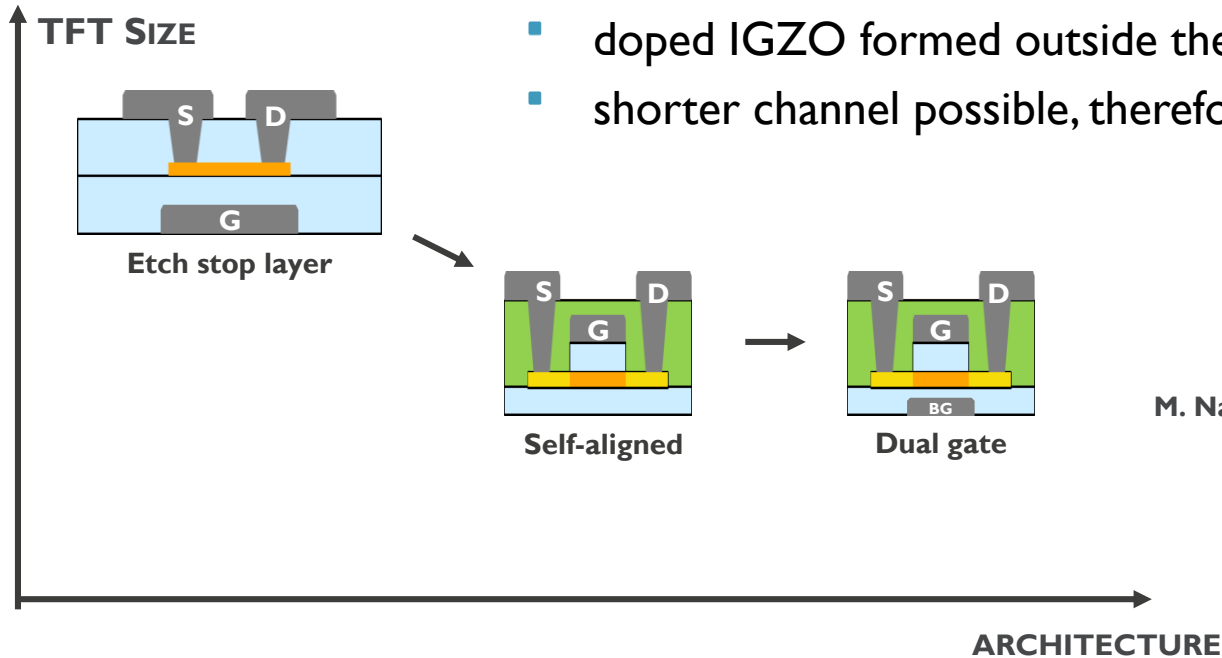


# TFT BACKPLANE

# TFT ARCHITECTURES

## SA TFT ENABLES MORE COMPACT FOOTPRINT

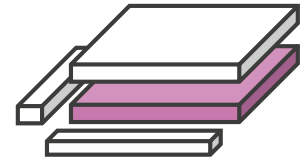
- less parasitics in self-aligned TFT
- doped IGZO formed outside the gate area
- shorter channel possible, therefore smaller footprint



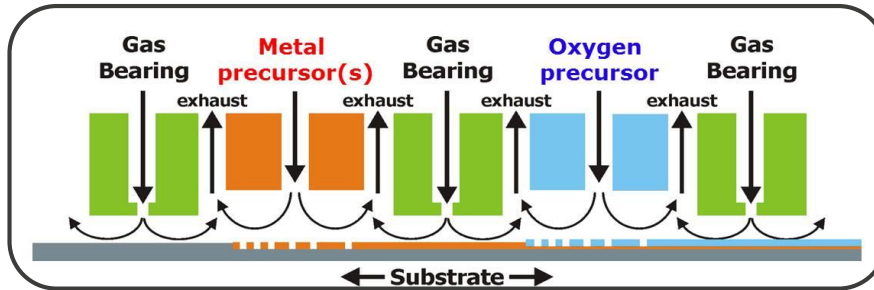
M. Nag et al., SID2015

# NEW SEMICONDUCTORS

## SPATIAL ALD ENABLES HIGH QUALITY IZO TFTS

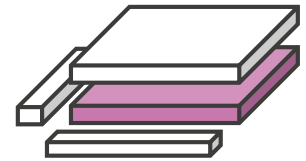


- spatial separation of half reactions instead of time-separated
- deposition rate  $> 1$  nm/s at atmospheric pressure

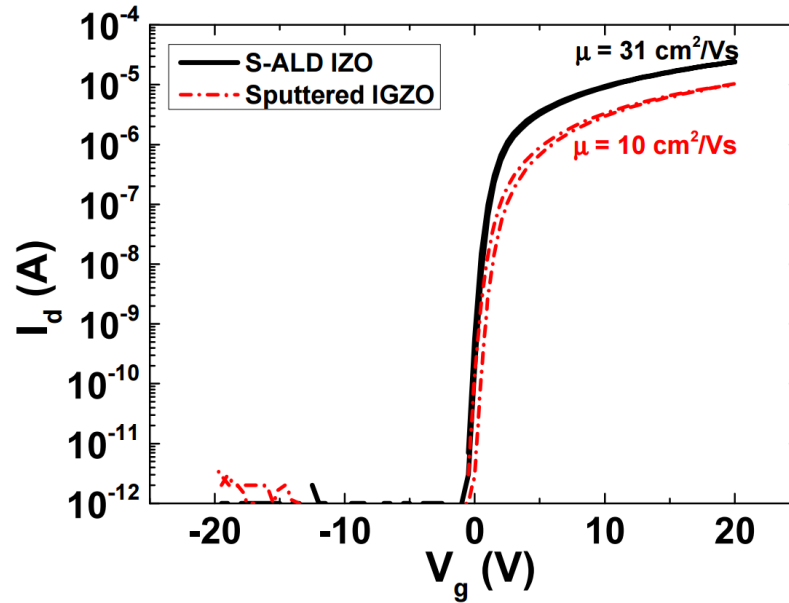


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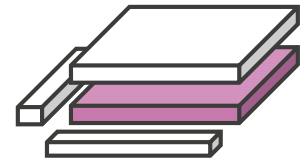


- IZO with mobility  $30 \text{ cm}^2/\text{Vs}$  – above IGZO

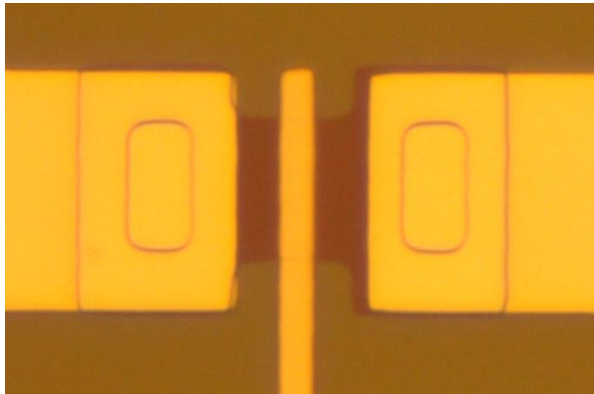


# MINIMUM FEATURE SIZE

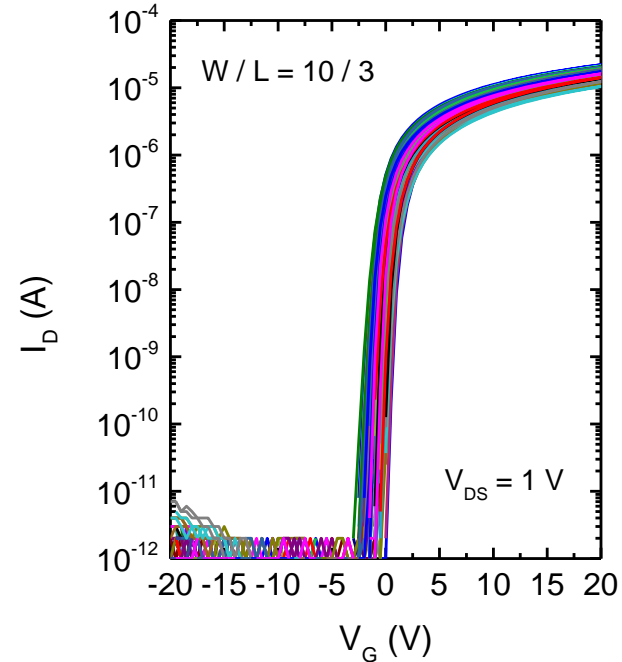
LIMITED BY TOOLS' RESOLUTION AND ACCURACY



- good uniformity over GENI plate down to 3  $\mu\text{m}$  channel length
- standard FPD tools limited to 1  $\mu\text{m}$



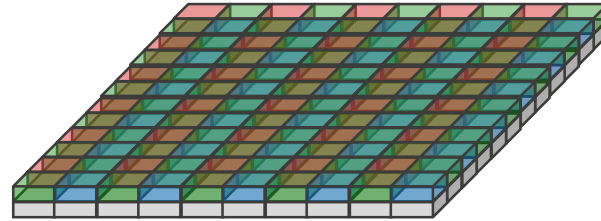
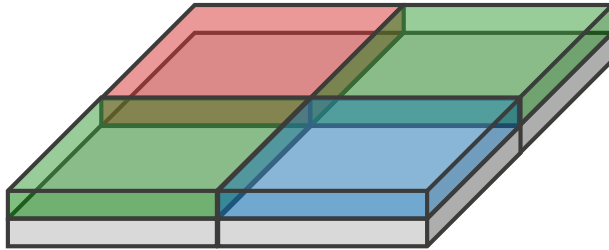
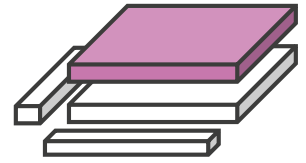
$W / L = 10 \mu\text{m} / 3 \mu\text{m}$





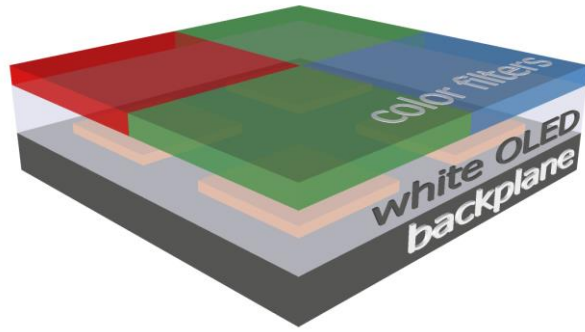
# OLED FRONTPLANE

# OLED FRONTPLANE SCALING

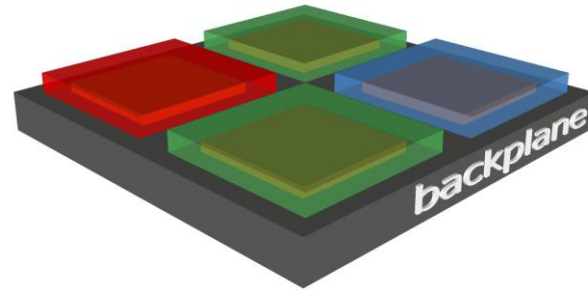




# WOLED VS. RGB OLED

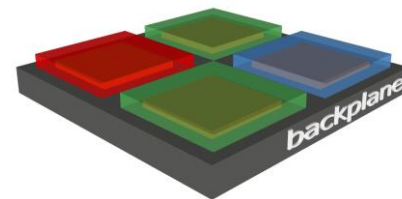
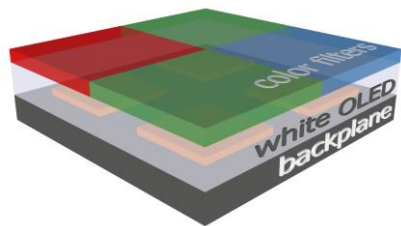


**WOLED** color-by-white



**RGB OLED** side-by-side

# WOLED VS. RGB OLED



## WOLED color-by-white

## RGB OLED side-by-side

pixel density

✓

limited by backplane (CMOS < 1 μm)

✗

limited by OLED dep. (FMM < 800 ppi)

aperture ratio

✓

high

✗

low

brightness

✗

limited by color filters

✓

optimum for each color

power

✗

high

✓

low

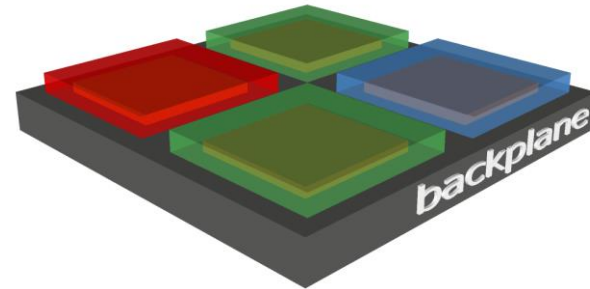
typical usage



# WOLED VS. RGB OLED

## FABRICATION METHODS

- FMM – Fine Metal Masking
  - difficult above 600-800 ppi
- IJP – Inkjet Printing
  - soluble materials needed
- photolithography
  - challenging chemically



**RGB OLED** side-by-side

# RGB OLED BY PHOTOLITHOGRAPHY

## DISRUPTIVE TECHNOLOGY

### **OPPORTUNITY:**

high pixel density / high aperture ratio / multicolor / large substrate size

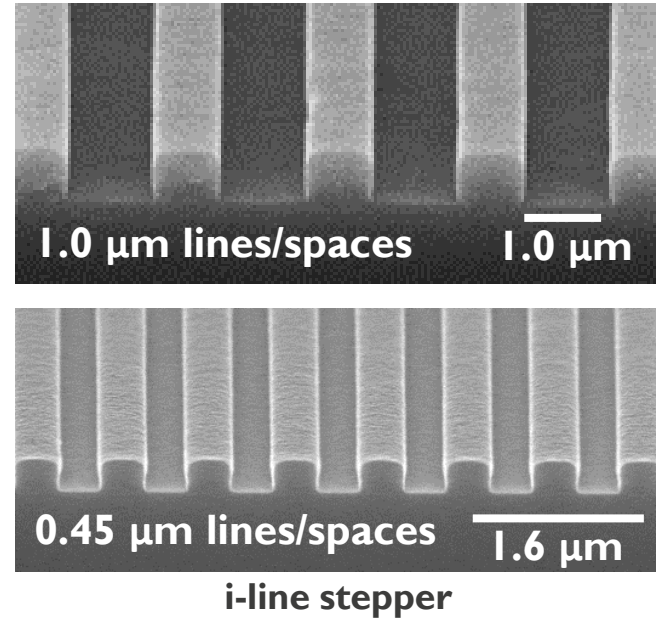
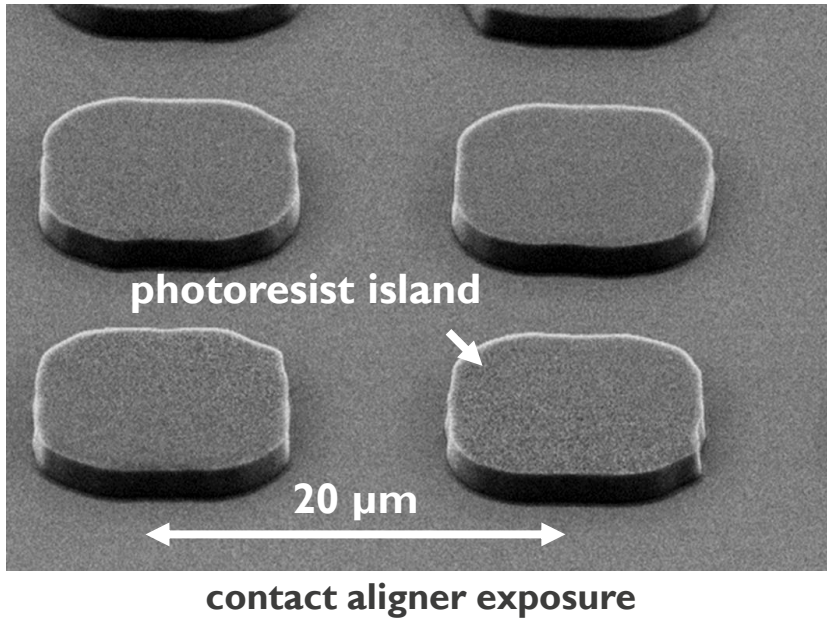
### **CHALLENGE:**

photolithography compatible with OLEDs



# PHOTORESIST RESOLUTION

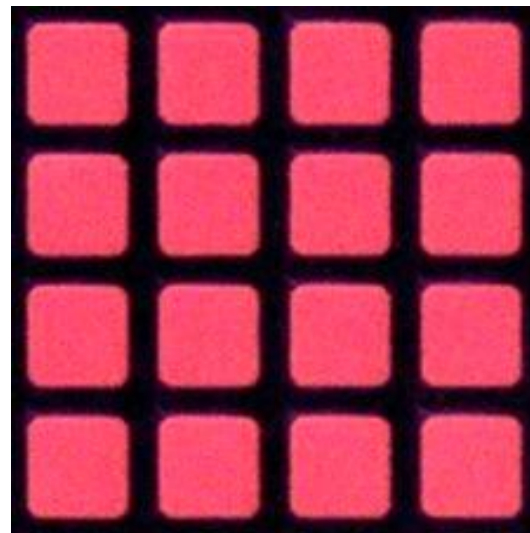
## 0.45 MICRON LINES/SPACES FEASIBLE



# HIGH APERTURE RATIO

## BETTER USAGE OF THE ACTIVE AREA

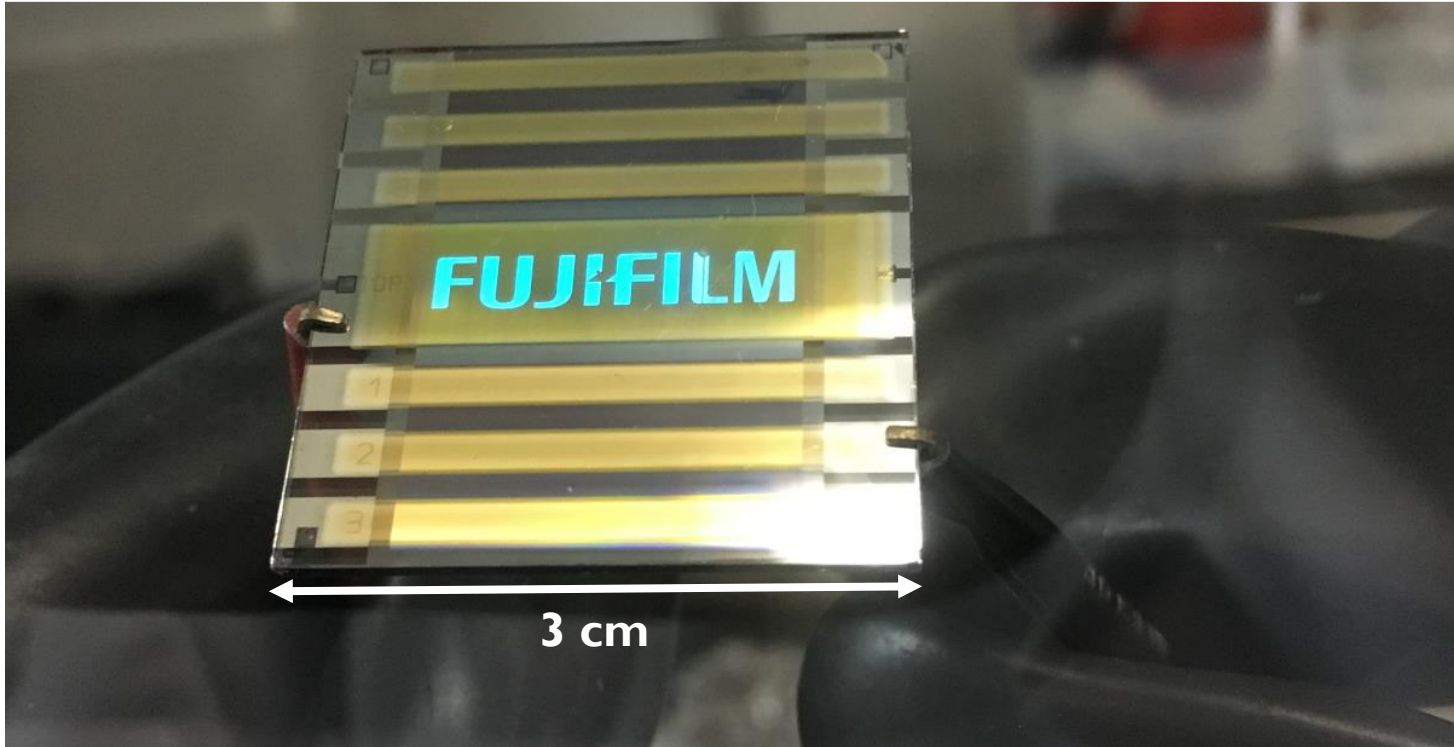
- targets:
  - minimum pixel spacing – below 1  $\mu\text{m}$
  - maximum emitting area
- higher aperture ratio yields longer lifetime



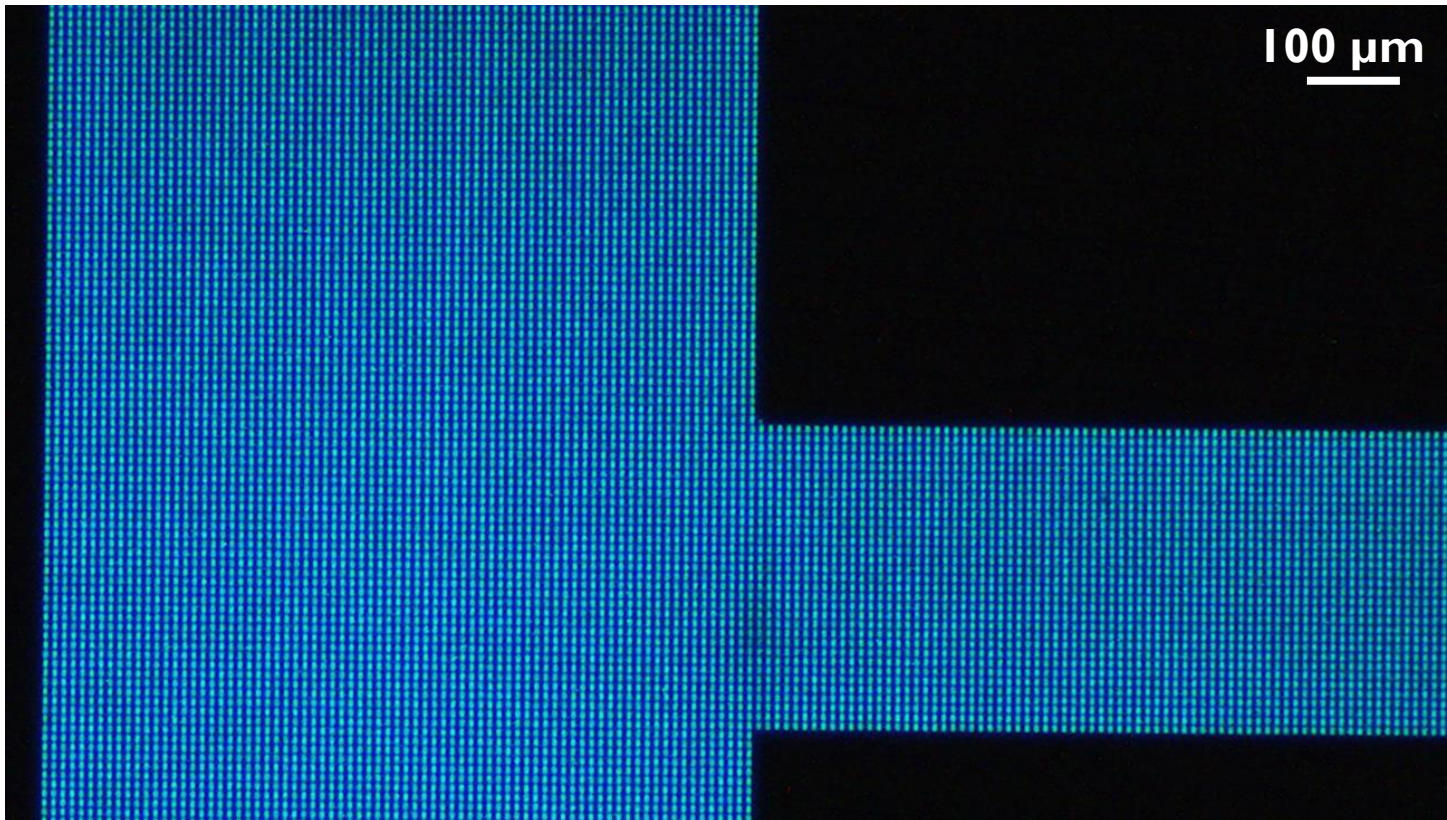
photoluminescence

# 2500 PPI PASSIVE DISPLAY: FLUORESCENT BLUE

1900x600 PIXELS, PASSIVE DISPLAY, TOP EMISSION

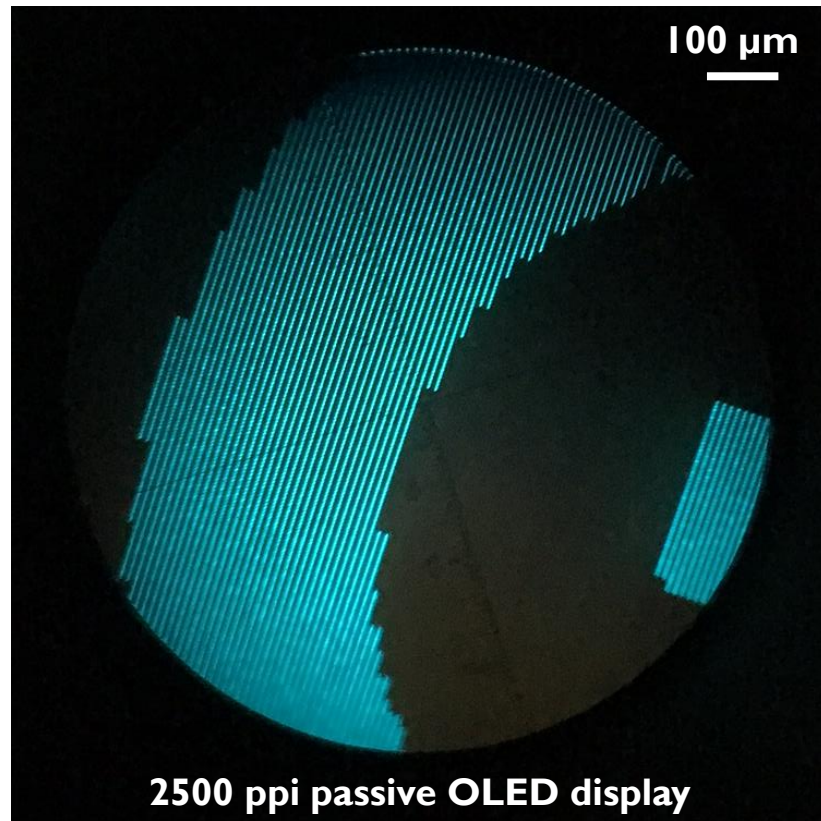
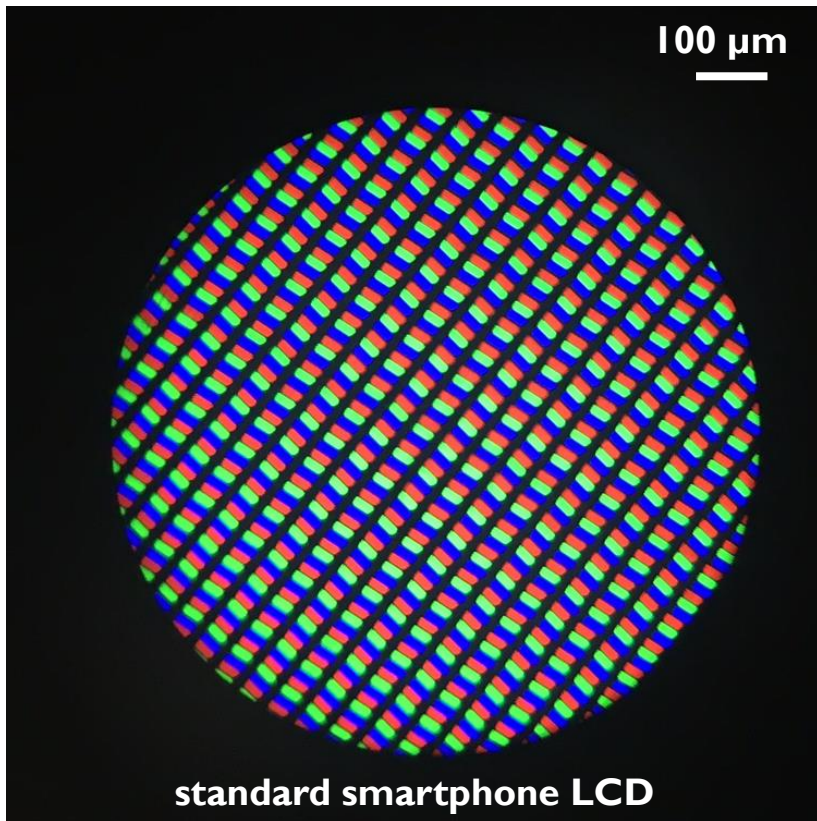


# 2500 PPI PASSIVE DISPLAY: FLUORESCENT BLUE



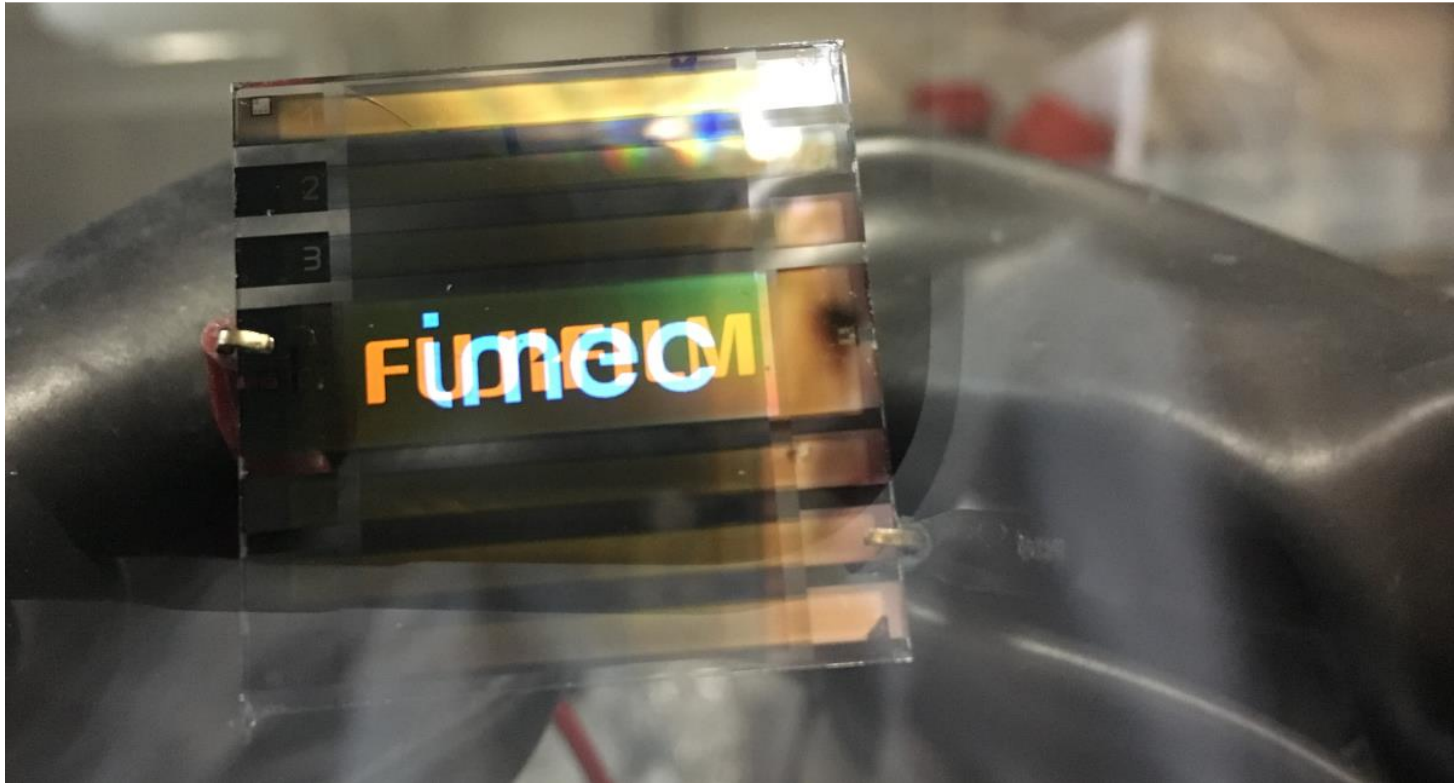


# PASSIVE OLED DISPLAY DEMO

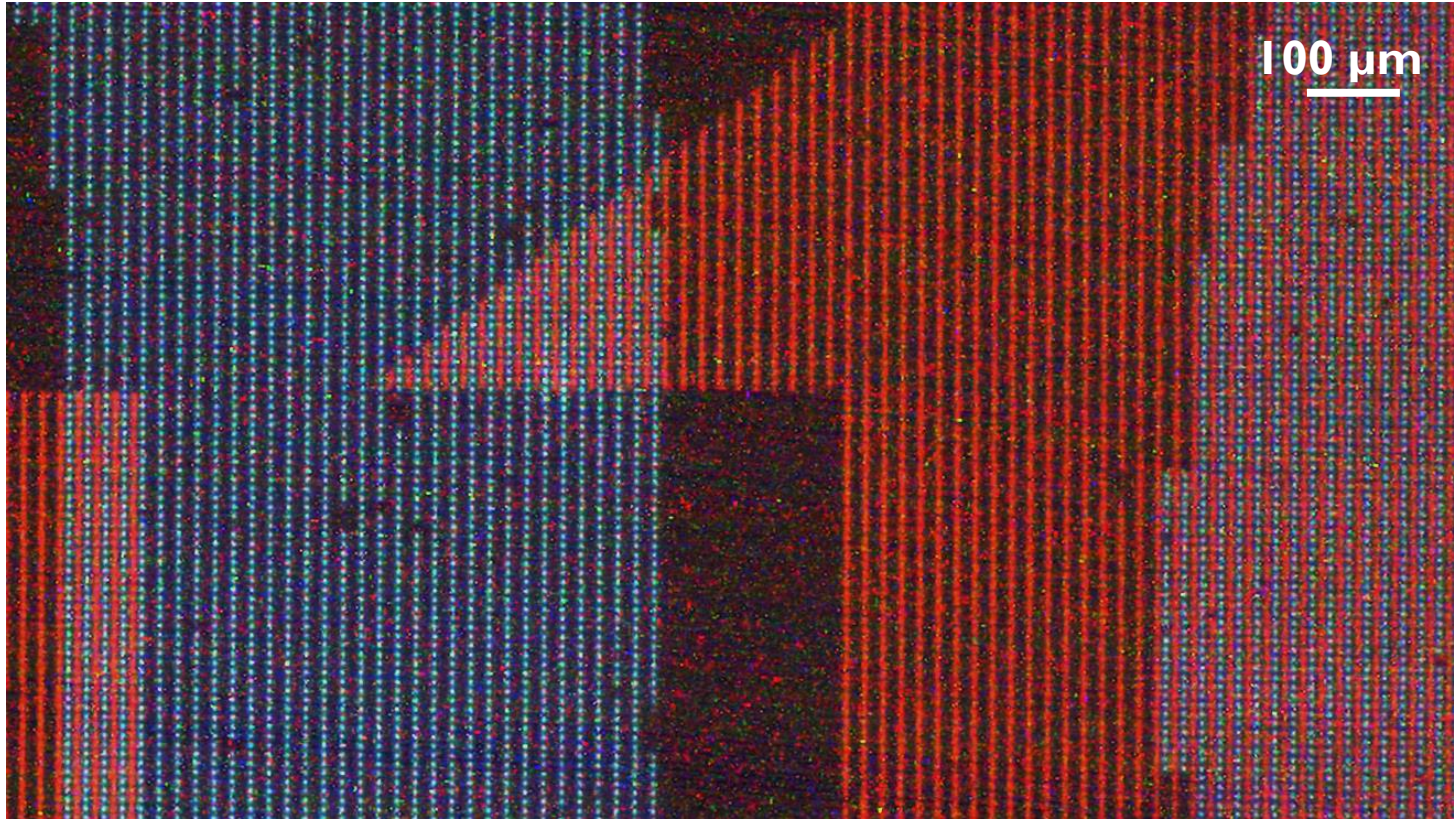


# I250 PPI DOUBLE COLOR – ORANGE/BLUE

I 900x600 SUBPIXELS, PASSIVE DISPLAY, TOP EMISSION

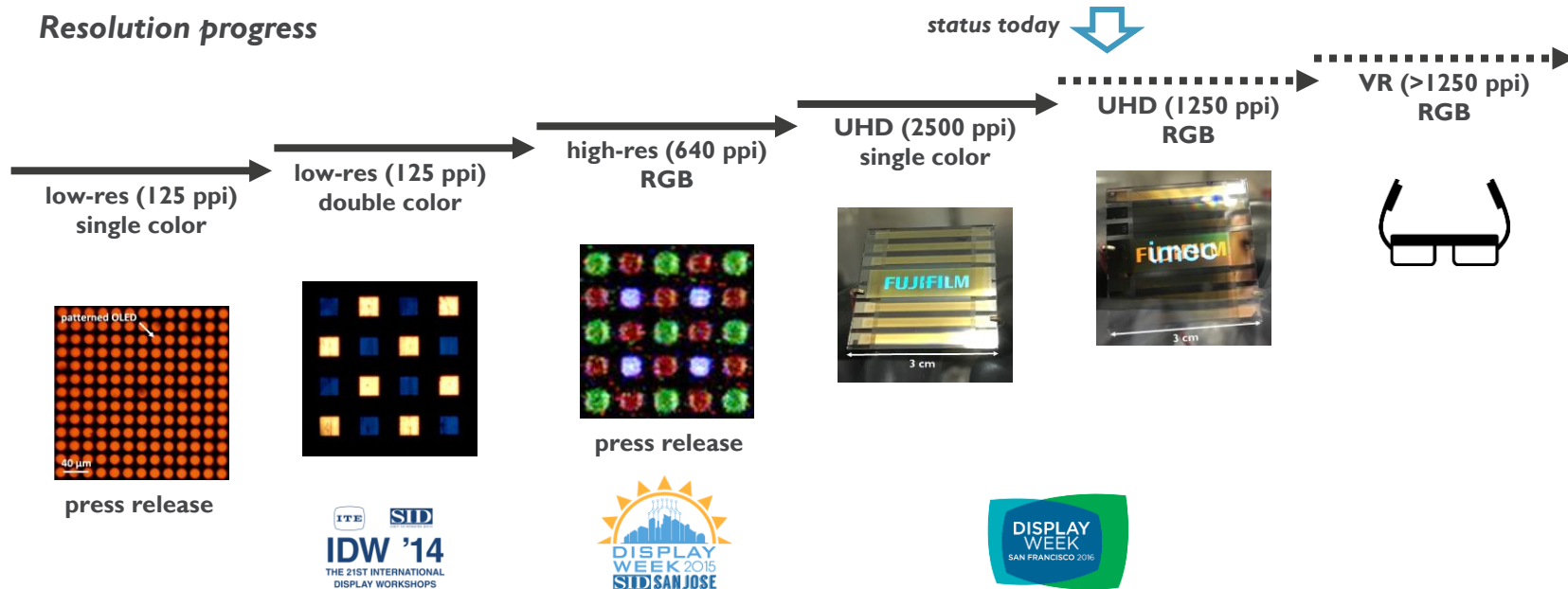


# I250 PPI DOUBLE COLOR – ORANGE/BLUE



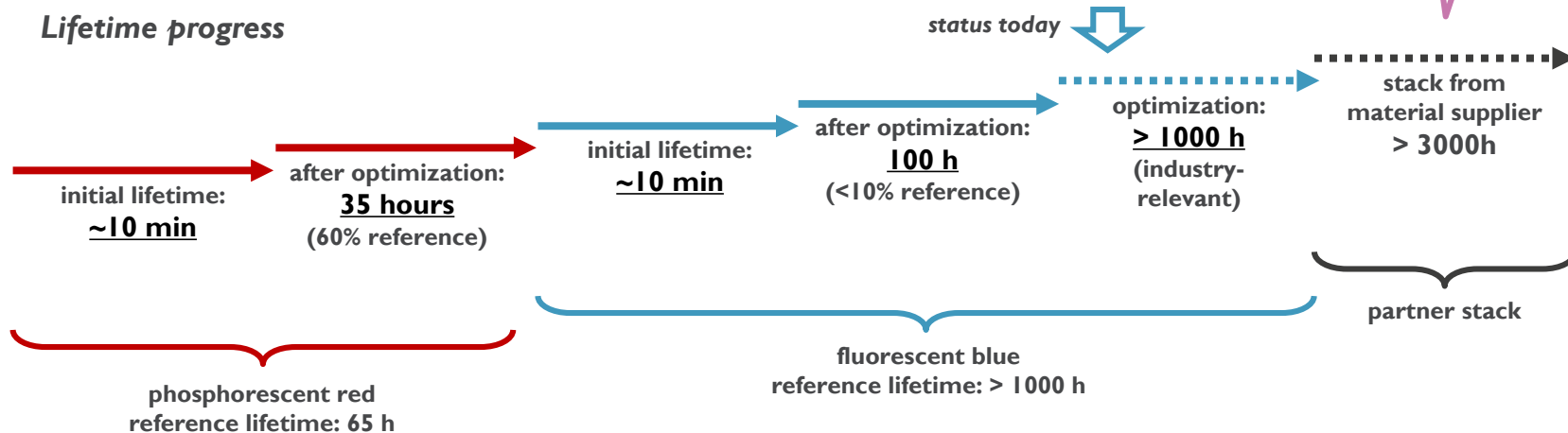
# HIGH RESOLUTION OLED PATTERNING PROGRESS

## TACKLING 2 MAIN CHALLENGES: RESOLUTION AND LIFETIME



# HIGH RESOLUTION OLED PATTERNING PROGRESS

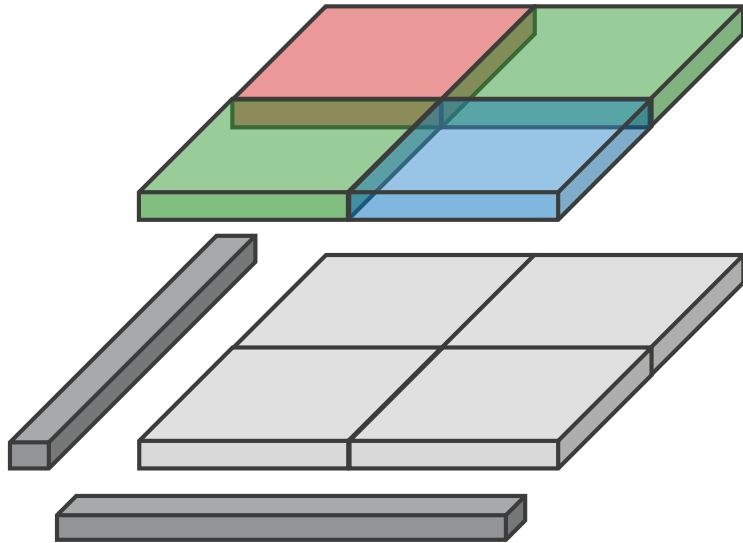
## TACKLING 2 MAIN CHALLENGES: RESOLUTION AND LIFETIME



# SUMMARY

# TOWARDS HIGHER PIXEL DENSITY

IMPROVEMENTS IN 3 AREAS:



**FRONTPLANE**

RGB resolution  
higher aperture ratio

**BACKPLANE**

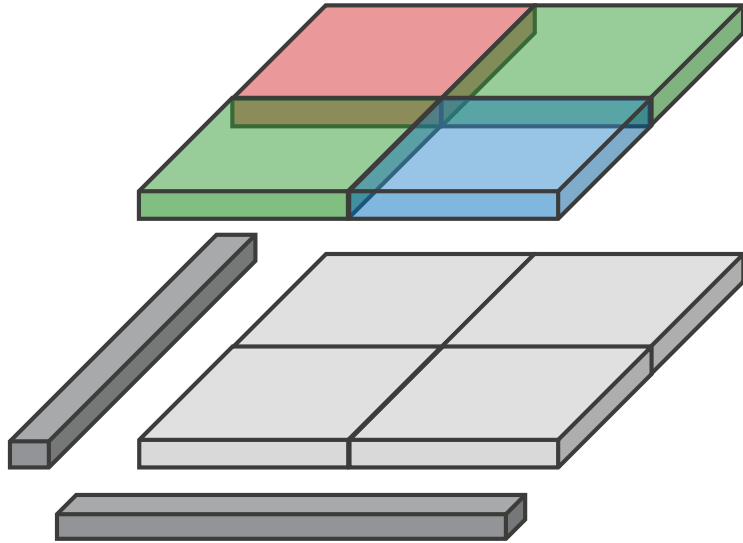
better semiconductors  
compact architectures  
process resolution

**DRIVING**

integrated drivers  
PWM scheme

# TOWARDS HIGHER PIXEL DENSITY

IMPROVEMENTS IN 3 AREAS:



RGB resolution  
higher aperture ratio

better semiconductors  
compact architectures  
process resolution

integrated drivers  
PWM scheme

**OLED patterning by litho**

**spatial ALD IZO  
2T1C, self-aligned TFT**

**integrated gate driver  
digital current driving**



# imec magazine

NOVEMBER 2016

## VIDEO

**In pursuit of intelligent swarms of robots**

## FROM THE LABS

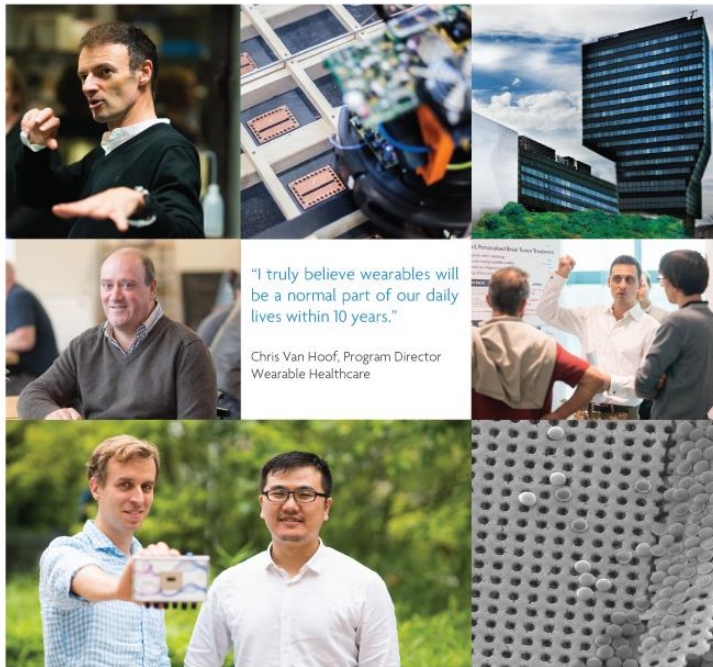
**Chips must learn how to feel pain**

## OPINION

**Getting all aboard the digital bandwagon!**

## BUSINESS

**Imec builds springboard for tech entrepreneurs**



고맙습니다



imec

SMALL PITCH, HIGH RESOLUTION – SCALING OF OLED DISPLAYS

PAWEL.MALINOWSKI@IMEC.BE





embracing a better life

# IMEC / HOLST FLEXIBLE AMOLED TRACK RECORD



- S. Steudel et al. “Flexible AMOLED Display with Integrated Gate Driver Operating at Operation Speed Compatible with 4k2k”, 29.4, SID Display Week 2015
- J. Genoe et al. “Integrated Line Driver for Digital Pulse-Width Modulation Driven AMOLED Displays on Flex”, J. Solid-State Circuits 50(1), 2015
- M. Nag et. “Dual-Gate Self-Aligned a-IGZO TFTs using 5-Mask Steps”, IDW 2015
- G. Gelinck et al. “Integration of Flexible AMOLED Displays Using Oxide Semiconductor TFT Backplanes”, 32.2, SID Display Week 2014
- J. Genoe et al. ISSCC 2014
- B. Cobb et. “Flexible Low-Temperature Solution-Processed Oxide-Semiconductor TFT Backplanes for Use in AMOLED Displays”, 13.4, SID Display Week 2014
- A. Bhoelokam et al., “Impact of etch stop layer on negative bias illumination stress of amorphous Indium Gallium Zinc Oxide transistors”, ESSDERC 2014
- M. Nag et al. “Flexible AMOLED Display and Gate Driver with Self-Aligned IGZO TFTs on Plastic Foil”, 20.1, SID Display Week 2014
- Y. Fukui et al. “Full Color Flexible Top-Emission AMOLED Display on Polyethylene Naphthalate (PEN) Foil with IGZO TFT Backplane”, 18.4L, SID Display Week 2013
- F. Li et al. “Flexible Barrier Technology for Enabling Rollable AMOLED Displays and Upscaling Flexible OLED Lighting”, 18.3, SID Display Week 2013

# IMEC / HOLST ORGANIC PATTERNING TRACK RECORD



- T.H. Ke et al. “Effect of Integrated Protection Layer on Photolithographic Patterned OLED stack,” 23rd International Display Workshops, IDW’16, Fukuoka, JP, 2016.
- P.E. Malinowski et al. “Multicolor 1250-ppi OLED Arrays Patterned by Photolithography”, paper 74.3, SID Display Week, San Francisco, 2016.
- P.E. Malinowski et al. “Organic Photodetectors with Active Layer Patterned by Lithography”, IEEE Sensors 2015, Busan, KR, 2015.
- T.H. Ke et al. “High aperture ratio organic light emitting diodes (OLED) pixels with 640 ppi resolution realized by CA i-line photolithography”, 22nd International Display Workshops, IDW’15, Otsu, JP, 2015.
- P.E. Malinowski et al. “Patterning of multicolor OLEDs with ultra-high resolution by photolithography”, paper 16.3, SID Display Week, San Jose, 2015.
- P. E. Malinowski et al. „Photolithographic patterning of organic photodetectors with a non-fluorinated photoresist system,” Organic Electronics 15 (10), 2014
- P.E. Malinowski et al. “Patterning of multicolor OLEDs with ultra-high resolution by photolithography”, 21st International Display Workshops, IDW’14, Niigata, JP, 2014 (Best Paper Award).